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GRANULAR MATERIALS FOR UV FILTER. (U)
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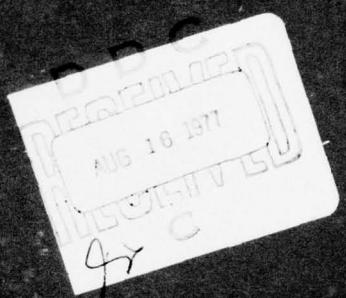
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REPORT DOCUMENTATION PAGE		READ INSTRUCTIONS BEFORE COMPLETING FORM	
1. REPORT NUMBER		2. GOVT ACCESSION NO.	
<i>Fiscal report. 1 May 76 - 31 Apr 77</i>		3. RECIPIENT/CATALOG NUMBER	
4. TITLE (and Subtitle)		5. TYPE OF REPORT & PERIOD COVERED	
<i>GRANULAR MATERIALS FOR UV FILTER.</i>		Final Report (5-1-76 to 4-30-77)	
		6. PERFORMING ORG. REPORT NUMBER	
		PRRL-77-CR-19	
7. AUTHOR(s)		8. CONTRACT OR GRANT NUMBER(s)	
E. K. Sichel and J. I. Gittleman		(14) (15) N00014-76-C-0858 new	
9. PERFORMING ORGANIZATION NAME AND ADDRESS		10. PROGRAM ELEMENT, PROJECT, TASK AREA & WORK UNIT NUMBERS	
RCA Laboratories Princeton, New Jersey 08540			
11. CONTROLLING OFFICE NAME AND ADDRESS		12. REPORT DATE	
Office of Naval Research Department of the Navy Arlington, Virginia 22217		(11) May 1977	
14. MONITORING AGENCY NAME & ADDRESS (if different from Controlling Office)		13. NUMBER OF PAGES	
(12) [30P.]		31	
16. DISTRIBUTION STATEMENT (of this Report)		15. SECURITY CLASS. (of this report)	
Approved for public release; distribution unlimited.		Unclassified	
17. DISTRIBUTION STATEMENT (of the abstract entered in Block 20, if different from Report)		15a. DECLASSIFICATION/DOWNGRADING SCHEDULE	
		N/A	
18. SUPPLEMENTARY NOTES			
19. KEY WORDS (Continue on reverse side if necessary and identify by block number)			
Granular metal		Magnesium	
Cermets		Magnesium fluoride	
Optical filter			
Maxwell-Garnett theory			
20. ABSTRACT (Continue on reverse side if necessary and identify by block number)			
<p>We have tested the potential of several sputtered cermets as a component in a solar-blind UV filter. Films made of metal grains embedded in an insulating matrix may exhibit a strong optical absorption which is absent in the bulk metal. The dimensions of the grains are much smaller than the wavelengths of the radiation which is relevant to the filter problem. Under this condition, the optical</p>			

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properties of the cermet may be described by the Maxwell-Garnett theory. We co-sputtered Mg with MgO and MgF₂ and Al with Al₂O₃ and SiO₂. The optical absorption desired was found in cermets of Mg-MgF₂ when the MgF₂ sputtering target was a single crystal. The observed optical absorption band was broad and weak, due to small metal grain size. Grain growth is required before this material would be suitable for an optical filter. However, it was not possible to promote grain growth by annealing because of reaction with oxygen trapped in the MgF₂ matrix which was porous. It is apparent that nonporous MgF₂ films must be obtained or another nonreactive matrix material must be found before a satisfactory filter can possibly be fabricated from cermet films. Thus we have not proved the cermet filter to be unattainable. Rather we have discovered the very difficult materials problems which must be overcome to obtain good filter characteristics.

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PREFACE

This Final Report describes research performed during the period 1 May 1976 through 30 April 1977, under Contract N00014-76-C-0858, at RCA Laboratories in the Materials Research Laboratory, Dr. James J. Tietjen, Director. The Project Supervisor was J. I. Gittleman and the Project Scientist was E. Sichel.

The Government Project Monitor is Dr. Van O. Nicolai.

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SECTION I
INTRODUCTION

The purpose of this research program was to test the potential of sputtered cermets as a component in a solar-blind UV filter. In particular, the cermet film should be opaque to wavelengths longer than 3000 Å, and transparent at shorter wavelengths. In this report we outline: (1) the theoretical basis of the expectation that an appropriate cermet would have the optical properties required for the filter, (2) the properties which the constituents of the cermet must have for optimum filter performance, and (3) the results of our experimental studies to determine the feasibility of making a cermet filter with the required properties.

The cermet films are formed by co-sputtering a metal and an insulator onto an appropriate substrate. If the constituents are immiscible and the volume fraction of the metal is sufficiently small, the resulting film contains an array of minute metal grains dispersed in an insulating matrix. In general, the size of the metal grains varies from several hundred angstrom units in diameter down to clusters of a few atoms. Thus, the metal grains are much smaller than the wavelengths of the radiation which are relevant to the filter problem.

Composite materials of this type exhibit optical properties quite different from those of the individual components. In addition to the sputtered cermets [1,2], metal dispersions such as colloids [3] and discontinuous metal films [4] have been shown to exhibit a strong optical absorption which is absent in the bulk metal. An example of this is Au colloidal particles suspended in glass in which the absorption peak gives rise to a characteristic ruby-red color.

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1. R. W. Cohen, G. D. Cody, M. D. Coutts and B. Abeles, Phys. Rev. B8, 3689 (1973).
 2. E. B. Priestley, B. Abeles and R. W. Cohen, Phys. Rev. B12, 2121 (1975).
 3. R. H. Doremus, J. Chem. Phys. 42, 414 (1965); 40, 2389 (1964).
 4. R. W. Tokarsky and J. P. Marton, J. Appl. Phys. 45, 3051 (1974).

The required sharpness of the cutoff of a filter using this characteristic absorption band demands that the scattering time for the conduction electrons in the metal grains be about the same as that in the bulk metal. Since the boundaries of the grains dominate the electron scattering processes in the cermets, the diameter of the metal grains must be of the order of a few hundred angstrom units, as discussed in Section III. We did not expect to find such large metal grains in as-prepared films. However, considerable grain growth can sometimes be induced by annealing [5,6].

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5. H. L. Pinch, J. Vac. Sci. Technol. 12, 60 (1975).
 6. N. C. Miller, B. Hardiman, and G. A. Shirn, J. Appl. Phys. 41, 1850 (1970).

SECTION II

THEORY

There seems to be little doubt that the Maxwell-Garnett equation [7]

$$\frac{\epsilon - \epsilon_1}{\epsilon + 2\epsilon_I} = x \frac{\epsilon_m - \epsilon_I}{\epsilon_m + 2\epsilon_I} \quad (1)$$

relating the complex dielectric constant, ϵ , of the composite to those of the constituents (ϵ_m for the metal, and ϵ_I for the insulator) gives the best prediction of the optical constants of the sputtered cermets [8]. In Eq. (1), x is the volume fraction occupied by the metal. Furthermore, the metal grains are assumed to be spherical, small, compared with the wavelength and dispersed in the insulating matrix. The dielectric constant $\epsilon = (\epsilon_1 + i\epsilon_2)$ is related to the index of refraction, n , and extinction coefficient, k , as follows:

$$\epsilon_1 = n^2 - k^2 \text{ and } \epsilon_2 = 2nk.$$

The dielectric constant of a typical metal is complex and has two contributions.

Thus,

$$\epsilon_m = \epsilon_{IB} + \epsilon_{FE} = \epsilon_{m1} + i\epsilon_{m2} \quad (2)$$

where ϵ_{FE} is the contribution due to the free (conduction) electrons and ϵ_{IB} is the contribution due to bound electrons which can absorb photons by making an interband transition. As we shall see, it is essential for the free electron contribution to dominate ϵ_m in order to obtain a filter with sharp cutoff characteristics. In the case of the free electrons, there is a frequency, the plasma frequency, ω_p , at which the real part of $\epsilon_{FE} = 0$. For most metals the plasma wavelength λ_p ($= \frac{2\pi c}{\omega_p}$, c = speed of light) is about 1000 Å. At longer wavelengths $\text{Re}(\epsilon_{FE})$ is negative and diverges at infinite

7. J. C. Maxwell-Garnett, Philos. Trans. R. Soc. Lond. 203, 385 (1904); 205, 237 (1906).
 8. J. I. Gittleman and B. Abeles, Phys. Rev. B15, 3273 (1977).

wavelength. At shorter wavelengths it is positive, approaching unity as $\lambda \ll \lambda_p$. In general ϵ_{FE} is given by [9]

$$\epsilon_{FE} = 1 + i \frac{\omega_p^2 \tau}{\omega(1 - i\omega\tau)} , \quad (3a)$$

$$\text{Re}(\epsilon_{FE}) = \left(1 - \frac{\omega_p^2 \tau^2}{1 + \omega_p^2 \tau^2}\right) , \quad (3b)$$

$$\text{Im}(\epsilon_{FE}) = \frac{\omega_p^2 \tau}{\omega(1 + \omega_p^2 \tau^2)} , \quad (3c)$$

where τ is the scattering time of the conduction electrons and $\omega = 2\pi c/\lambda$.

When a granular metal is formed, as in a cermet, then it can readily be seen from Eq. (1) that the composite not only exhibits a plasma resonance similar to an ordinary metal, but also exhibits an anomalous absorption. If we can ignore the imaginary part of the dielectric constants it can be seen that $\epsilon = 0$ (plasma resonance) when the left-hand side of Eq. (1) becomes $-1/2$. This will occur at a frequency ω' for which

$$\epsilon_m(\omega') = -\frac{2(1-x)}{1+2x} \epsilon_I . \quad (4)$$

Thus, for a plasma resonance to occur in the composite, $\epsilon_m(\omega')$ must be negative. At the anomalous absorption, $\omega = \omega_a$ and the left-hand side of Eq. (1) approaches unity since $\epsilon(\omega_a) \gg \epsilon_I$. This occurs if

$$\epsilon_m(\omega_a) = -\frac{2+x}{1-x} \epsilon_I \quad (5)$$

and again $\epsilon_m(\omega_a)$ must be negative. If ϵ_{IB} is neglected and the electron scattering time τ is large so that $\omega_p \tau$, $\omega_p' \tau$, and $\omega_a \tau$ are all large compared with unity, $\epsilon_m(\omega) = 1 - (\frac{\lambda}{\lambda_p})^2$ from Eqs. (3), (4) and (5) give

$$\frac{\lambda'^2}{\lambda_p^2} = \frac{\lambda^2}{\lambda_p^2} \left[1 + \frac{2(1-x)}{1+2x} \epsilon_I\right] \quad (6a)$$

$$\text{and} \quad \frac{\lambda^2}{\lambda_a^2} = \frac{\lambda^2}{\lambda_p^2} \left[1 + \left(\frac{2+x}{1-x}\right) \epsilon_I\right] \quad (6b)$$

9. J. M. Ziman, *Principles of the Theory of Solids*, (Cambridge University Press, 1965) Chapter 8.

The real part of ϵ_{IB} is generally positive. Therefore, if it is too large to be neglected, the magnitude of ϵ_{FE} must be larger than ϵ_{IB} for the composite to exhibit a plasma resonance and an absorption anomaly. In this case we obtain from Eq. (4)

$$(\lambda_p')^2 = (\lambda_p)^2 [1 + \frac{2(1-x)}{1+2x} \epsilon_I + \epsilon_{IB} (\omega_p')] \quad (7)$$

and a similar expression from Eq. (5).

Qualitatively, the optical properties of a cermet film exhibiting a plasma resonance and an absorption anomaly can be described as follows: For $\lambda < \lambda_p'$ or $\lambda > \lambda_a$ the film is transmitting, its behavior similar to a transparent dielectric; for $\lambda_p' < \lambda < \lambda_a$ the film is highly reflecting and absorbing with little transmittance, behavior similar to that of a metal. In Fig. 1 is shown the real and imaginary parts of ϵ as a function of wavelength, computed from Eq. (1). Here $\epsilon_m = \epsilon_{FE}$, $\epsilon_I = 3.7$ and $\lambda_p = 1200 \text{ \AA}$ and $\tau = 1.0 \times 10^{-14} \text{ s}$. It should be noted the wavelength dependence of ϵ is similar to that of an ionic crystal near its *restrahlen band*. This behavior, of course, is the basic property needed for the filter.

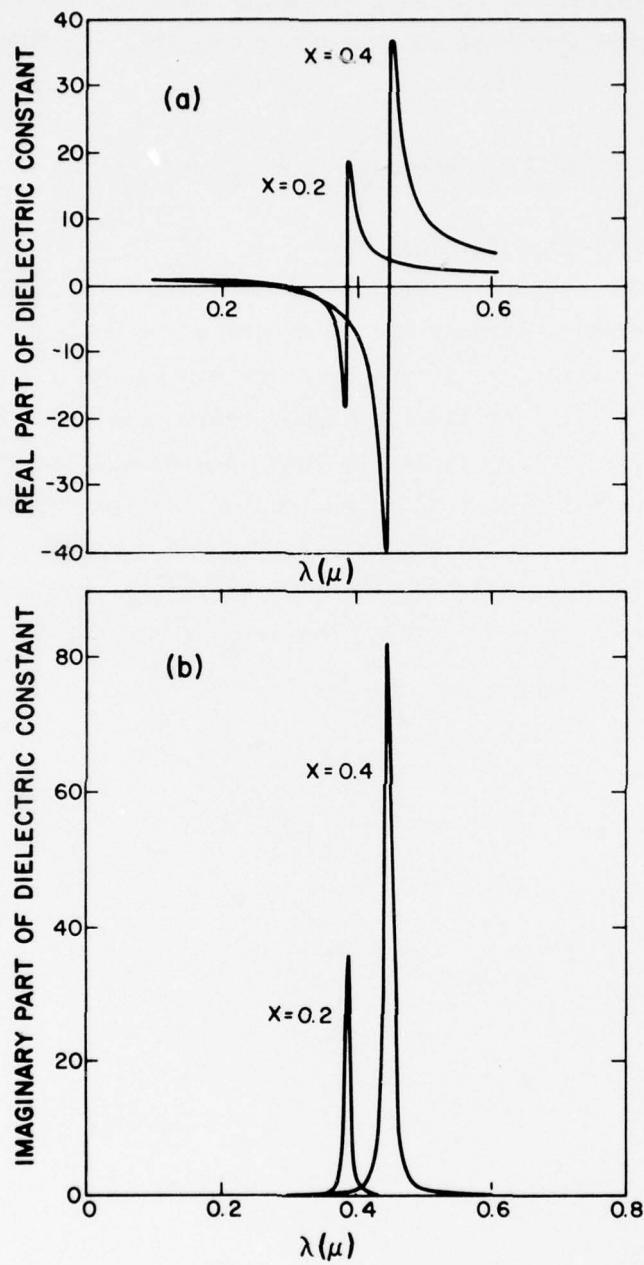


Figure 1. (a) The real part, and (b) the imaginary part of the dielectric constant of a free electron metal calculated from Eqs. (1) and (3) for two values of the metal volume fraction, x . The plasma wavelength (λ_p) is 1200 Å, $\tau = 1.0 \times 10^{-14}$ s and $\epsilon_I = 3.7$.

III. MATERIAL REQUIREMENTS

This section is concerned with the properties of the constituents of the cermet which are needed to obtain good filter characteristics. In the case of the insulating matrix there are two requirements. The insulator must be transparent in the wavelength range of interest and its dielectric constant must be sufficiently large to permit "tuning" of the filter by adjusting the composition (see Eq. (6)). For the purposes of demonstrating feasibility, the requirement of transparency is the only important one. Finding the optimum insulator which maximizes tunability was considered an unnecessary complication at this stage.

The severest requirements rest with the metal component. First, its optical properties must not be dominated by interband transitions. The transition metals are not suitable for this reason. In the noble metals such as Au and Ag, ϵ_{IB} is not so large as to preclude the desired properties, but it is large enough (See Eq. (7)) to place the resonance at wavelengths too long to be useful [1]. Promising candidates can be found among the alkali metals, alkaline earth metals, and aluminum. The most favorable of these are Al and Mg, whose optical properties are dominated by free electrons, and these metals are relatively easy to handle. Magnesium, ($\lambda_p \approx 1200 \text{ \AA}$) is a somewhat better prospect than aluminum ($\lambda_p \approx 900 \text{ \AA}$).

Another requirement is that the metal grains be sufficiently large. In a bulk pure metal at room temperature the conduction electrons have a mean free path of about 200 \AA corresponding to a scattering time τ of about $1 \times 10^{-14} \text{ s}$. Scattering is due to collisions with phonons. In cermets, where the mean grain size may be 20 \AA or less and electron scattering is dominated by collisions with the boundary, τ will be correspondingly less. Excessively small values of τ will have a drastic effect on the quality of the filter. In general, the smaller the value of τ , the weaker and broader will be the anomaly shown in Fig. 1. The broadening reduces the sharpness of the filter cutoff and the weakening will enhance the effect of interband transitions. Figure 2 shows the optical density of three hypothetical cermet films. The metal component of each is a free electron metal. The films differ only in the values of τ . Here the rounding due to excessive scattering becomes clear. Therefore,

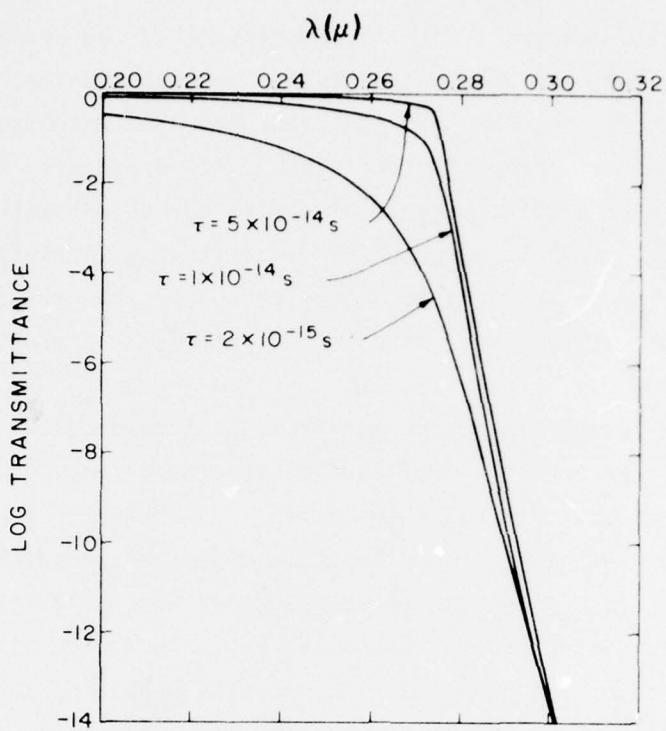


Figure 2. Log of transmittance vs wavelength calculated for three cermets, each $0.75 \mu\text{m}$ thick and composed of 20 vol % free electron metal ($\lambda_p = 1270 \text{\AA}$) dispersed in Al_2O_3 . The mean electron scattering time of each is indicated in the figure.

it is absolutely essential that the metal grain size be controllable, presumably through heat treatment.

The following section outlines our experimental efforts. Both Al and Mg cermets have been studied and the degree to which they meet the above requirements will be discussed.

SECTION IV

RESULTS

Magnesium and aluminum were the metals of choice in this program because their optical properties are dominated by the conduction electrons.

A. MAGNESIUM CERMETS

We prepared thin films of Mg by evaporation and sputtering and by reactive sputtering in the presence of oxygen to test the stability of the films in the atmosphere.

The plasma frequency of Mg ($\lambda_p \approx 0.117 \mu$) can be computed from optical data [10]. The free electron contribution to the optical constants of Mg was generated for different values of τ using Eq. (3). The films should become more transparent in the ultraviolet than they are in the visible. This is characteristic of a (free electron) metal [9], of which magnesium is a good example [10]. Note that if the electron scattering time becomes too short, e.g. $\sim 10^{-16}$ s, the material would not behave like a metal. Figure 3 shows the computed optical density of a 500-Å film of pure Mg with scattering times $\tau = 10^{-15}$ s, 3×10^{-16} s, and 10^{-16} s.

Figure 4 shows the observed optical density of a thin film of Mg reactively sputtered with a small amount of oxygen. All optical measurements were done with a Cary 14 spectrophotometer and, below 1900 Å, with a Jarrell-Ash VUV spectrometer. The character of the results for $\lambda \gtrsim 0.3 \mu\text{m}$ indicate that metallic Mg was sputtered successfully. However, within a few days at room atmosphere, the Mg films had oxidized. Attempts to seal the surface with a layer of SiO_2 were unsuccessful, probably because the Mg films are porous. The solid curve in Fig. 5 is the optical density computed using the optical constants for pure Mg [10] ($\tau \approx 10^{-14}$ s). As can be seen, the agreement with theory is very good for $\lambda \gtrsim 0.3 \mu\text{m}$.

Although the general feature of Fig. 5 indicates metallic Mg, there is an excess absorption in the UV which is due to the presence of MgO. Sometimes,

10. H. J. Hagemann, W. Audat, and C. Kunz, Deutsches Elektronen-Synchrotron, 2 Hamburg 52, May 1974.
11. B. Abeles, "Granular Metal Films," *Applied Solid State Science* 6, 1976, Academic Press.

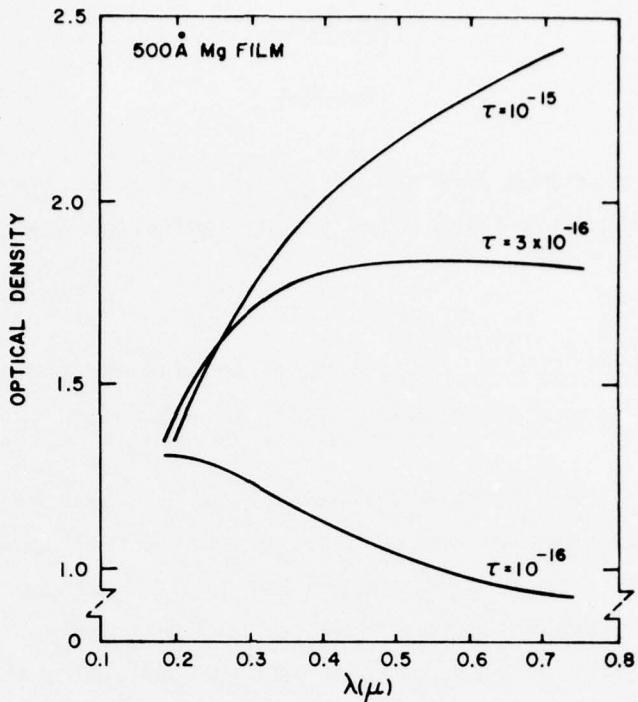


Figure 3. Optical density of thin films of Mg metal computed for various electron scattering times.

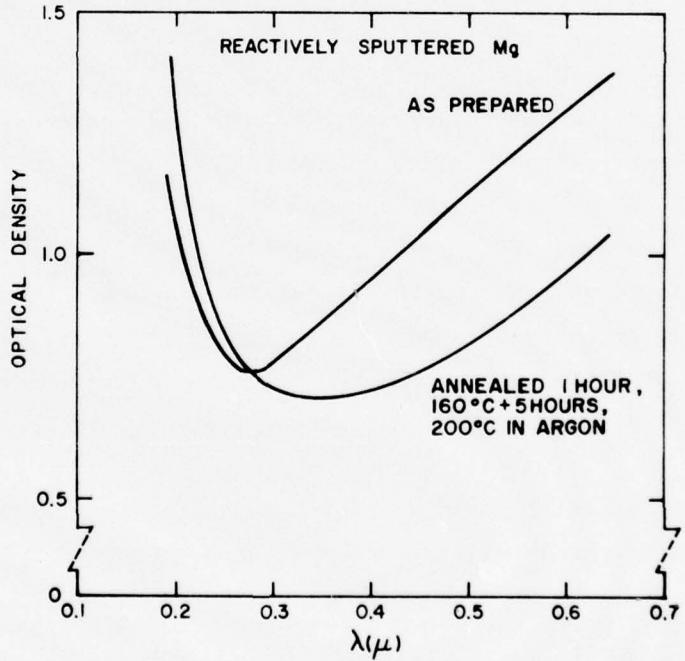


Figure 4. Optical density of thin films of reactively sputtered Mg, as prepared and annealed.

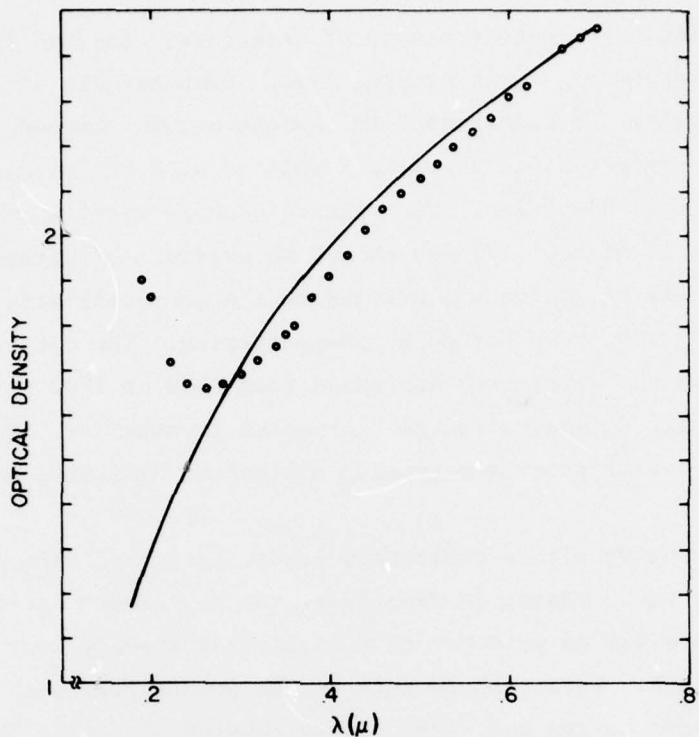


Figure 5. Optical density vs wavelength. Solid curve: computed for 500 Å. Mg film using published values of optical constants¹ ($\tau \approx 10^{-14}$ s). Points: Experimental data for 500-Å film of Mg sputtered in Ar containing 10^{-6} torr O₂.

annealing samples promotes grain growth in cermets or coalescence of metallic patches [11] in discontinuous films which increases the electron mean free path and increases τ . Annealing the thin films of Mg had the opposite effect: there was loss of Mg metal and an increase in the UV absorption as seen in Fig. 4. Since all annealing was done either in an inert atmosphere of argon or in a reducing atmosphere of hydrogen, we conclude that the films contained trapped atmospheric oxygen.

Composite materials with magnesium metal were prepared by sputtering. These included Mg-MgO, Mg-SiO₂, and Mg-MgF₂. We discuss each in turn.

Films of Mg, co-sputtered with MgO gave films whose optical density increased monotonically with energy from the visible to the ultraviolet. Annealing did not change the general features of the optical density spectrum. Annealing temperatures were generally about 200°C. Higher temperature did not improve the results. The rising absorption in the UV is probably due to the formation

of MgO containing high concentrations of vacancies. The MgO sputtering target was a compressed powder, a hot pressed disc. Such targets are porous and trap atmospheric oxygen. We expect that the excess oxygen trapped in the MgO target, (plus any MgO₂ present as an impurity,) reacted with the Mg metal, leaving no metallic Mg in the thin films. The optical density spectra of the Mg-MgO films was characteristic of MgO [12] and showed no evidence of either metallic behavior or of small Mg grains which would have a characteristic absorption peak.

Films of Mg-SiO₂ were formed by co-sputtering. The optical density rose monotonically as the wavelength decreased from 7000 to 1900 Å. There was no evidence of either an absorption peak or metallic behavior. We assume that during the sputtering process magnesium silicates, MgO, SiO, and Mg-Si compounds were formed.

Co-sputtering Mg with a compressed powder target of MgF₂ gave the familiar optical density curve rising in density as the wavelength decreased from 7000 to 2000 Å. There was no evidence of a dielectric anomaly, nor did annealing produce any change. We attribute this to the porous MgF₂ compressed powder target which traps oxygen gas. The excess absorption in the UV is probably due to the formation of MgO. On the other hand, when we co-sputtered Mg with single crystal MgF₂ the absorption peak predicted by theory was obtained. MgF₂ was selected as the insulating matrix because it is an insulator without oxygen and is not expected to react with Mg. Further, the single crystal MgF₂ target does not trap atmospheric oxygen as the compressed powder target does.

The predicted optical density spectra of Mg-MgF₂ is shown in Figs. 6 (a), 6 (b) and 6 (c) for different compositions and electron scattering times. The optical constants of MgF₂ were assumed to be $n = 1.4$, and $k = 0$. Our experimental results for films of Mg-MgF₂ are shown in Fig. 7. There is a dielectric anomaly near 2500 Å. Figure 8 shows the theoretical curves for different τ 's and the experimental spectrum for a 36 vol % Mg sample, all superimposed on the same graph. It can be seen that scattering time τ of about 2×10^{-16} s would result in good agreement between observation and the calculated optical density. If we assume the Fermi velocity $v_F \sim 2 \times 10^8$ cm/s, then $\ell \sim 4 \times 10^{-8}$ cm. This corresponds to a Mg grain consisting of a cluster of a few atoms.

12. A. J. Moses, ed., *Handbook of Electronic Materials*, Vol. 1, Optical Materials Properties, (Plenum Press, New York, 1971).

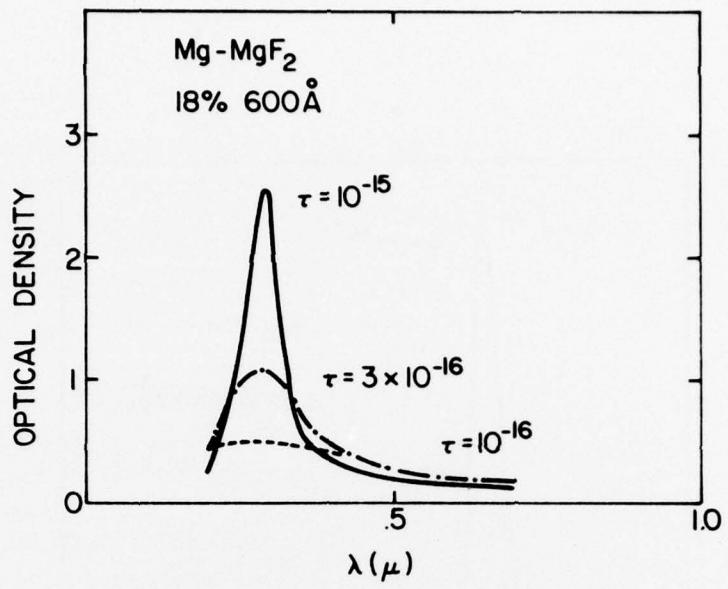


Figure 6(a). Theoretical optical density spectra of Mg-MgF₂ cermets for 18 vol % Mg metal embedded in MgF₂ matrix.

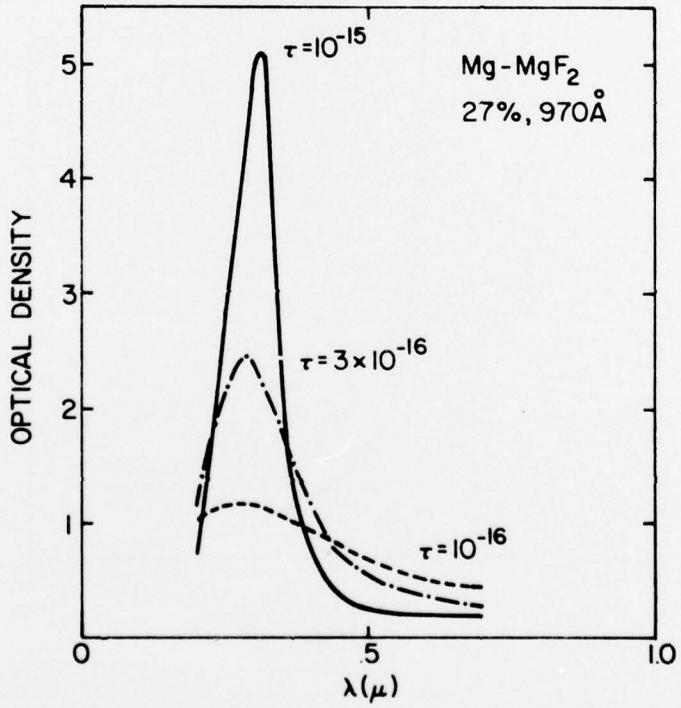


Figure 6(b). Theoretical optical density spectra of Mg-MgF₂ cermets for 27 vol % Mg metal embedded in MgF₂ matrix.

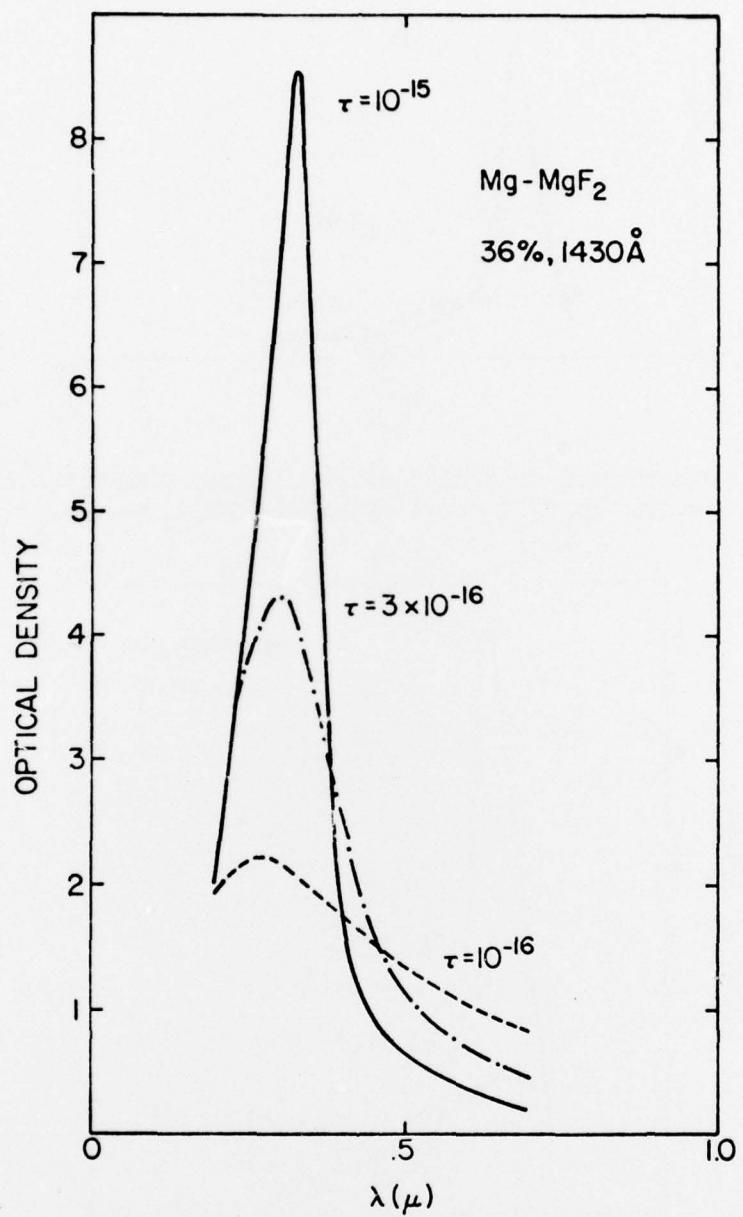


Figure 6(c). Theoretical optical density spectra of Mg-MgF₂ cermets for 36 vol % Mg metal embedded in MgF₂ matrix.

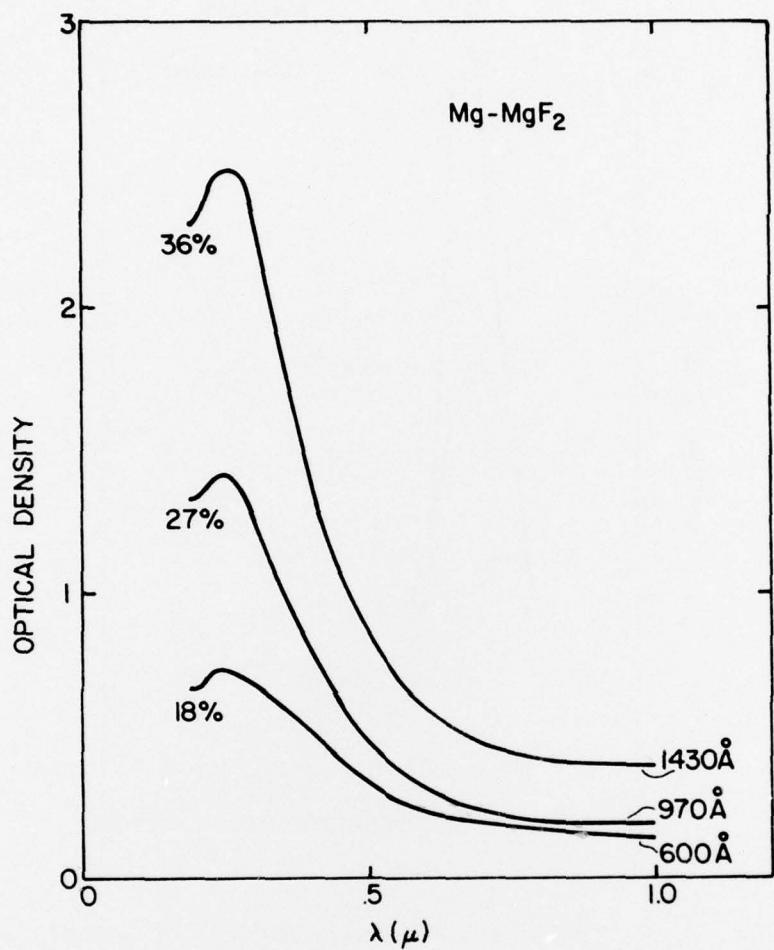


Figure 7. Experimental optical density spectra of Mg-MgF₂ cermets.

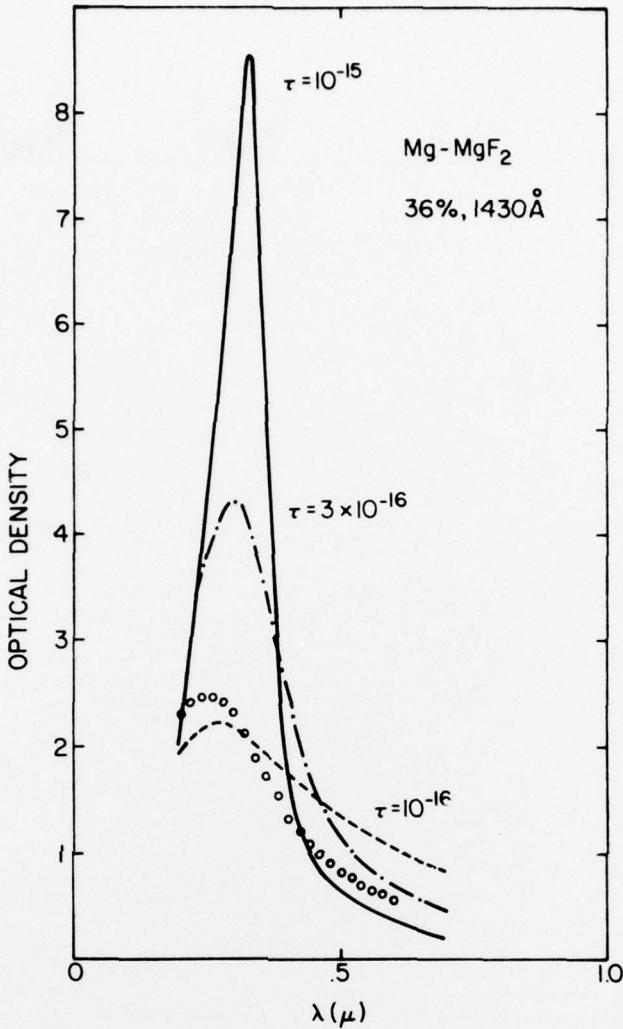
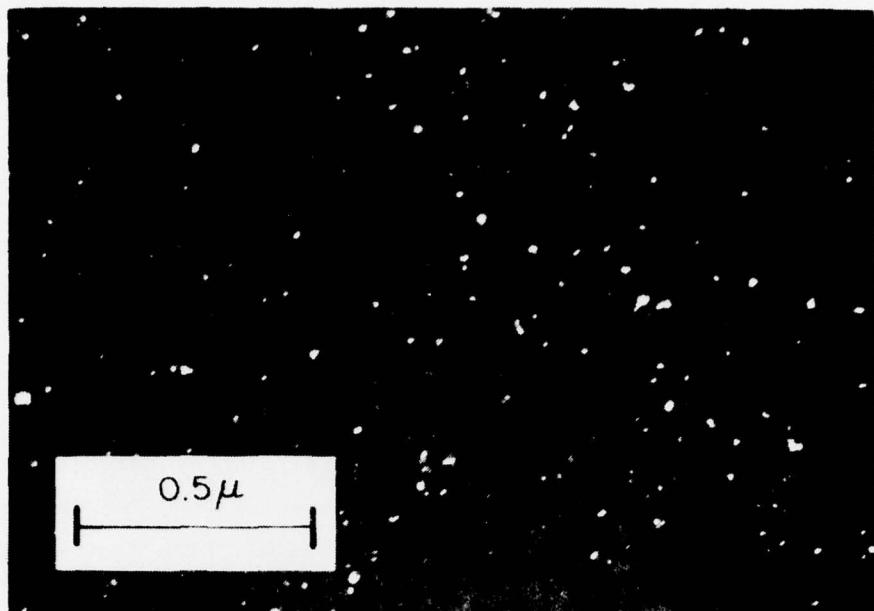


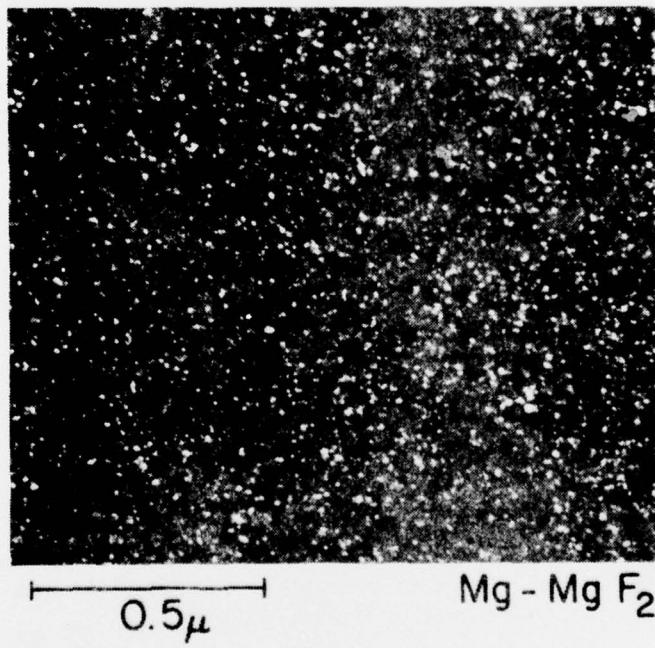
Figure 8. Theoretical optical density spectra of $\text{Mg}-\text{MgF}_2$ cermet for 36 vol % Mg metal embedded in MgF_2 matrix with experimental data (circles) superimposed.

Electron micrographs of the $\text{Mg}-\text{MgF}_2$ samples showed a variety of Mg grain sizes from 150 \AA down to the resolution of the microscope, about 20 \AA for magnesium. However, we believe that a larger number of magnesium grains exist in clusters of a few atoms. Figures 9 and 10 are dark-field micrographs of a 82 vol % Mg sample and a 43 vol % Mg sample. In Fig. 9, Mg metal was the only crystalline material that was found in the diffraction pattern. The visible (white) grains of Mg do not take up most of the volume, indicating that the



Mg - MgF₂

Figure 9. Transmission electron micrograph of Mg-MgF₂ cermet, nominally 82 vol % Mg.



Mg - Mg F₂

Figure 10. Transmission electron micrograph of Mg-MgF₂ cermet, nominally 43 vol % Mg.

rest of the Mg grains are oriented to diffract the electron beam out of the field of view. In Fig. 10 the visible grains are predominantly Mg metal, although a small fraction are MgO and MgO₂.

Auger electron analysis shows that the Mg-MgF₂ samples consist of a surface layer containing MgO and no metal. Below the oxidized layer, grains of metallic Mg are found, in addition to MgO, which give rise to the optical dielectric anomaly. The depth of the surface layer increases with the age of the specimen. These results suggest that the sputtered MgF₂ matrix is quite porous to atmospheric oxygen.

In Fig. 11 are shown the optical density spectra of 34 vol % Mg (nominal) and 77 vol % Mg (nominal) samples. The upper curve shows the characteristic metallic behavior, even including a broad interband absorption in the IR. Note that there is still some excess absorption in the UV, even in the metallic sample.

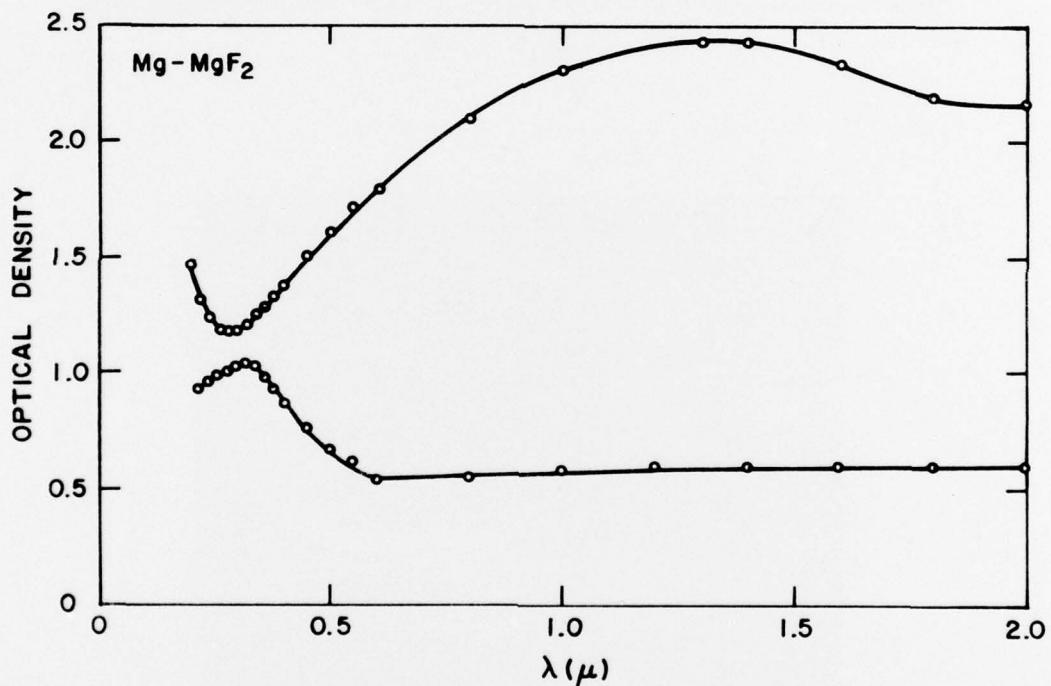


Figure 11. Experimental optical density spectra of Mg-MgF₂ cermets. The upper curve is nominally 77 vol % Mg and the lower curve is nominally 34 vol % Mg.

Examination of Mg-MgF₂ samples of Mg F₂ substrates in the VUV to 1250 Å showed that the optical density of the MgF₂-rich samples in Fig. 7 does not drop to low values on the high energy side of the absorption peak. We attribute this to color centers in the MgF₂, or to the formation of MgO. It has been shown that the packing density of MgF₂ may be as low as 74% [13] unless the films are deposited on heated substrates. A porous material will be easily attacked by oxygen. Annealing did not promote grain growth but resulted in the apparent loss of Mg as shown in Fig. 12. From the results of the Auger spectroscopy, we conclude that the loss results from reaction with absorbed oxygen.

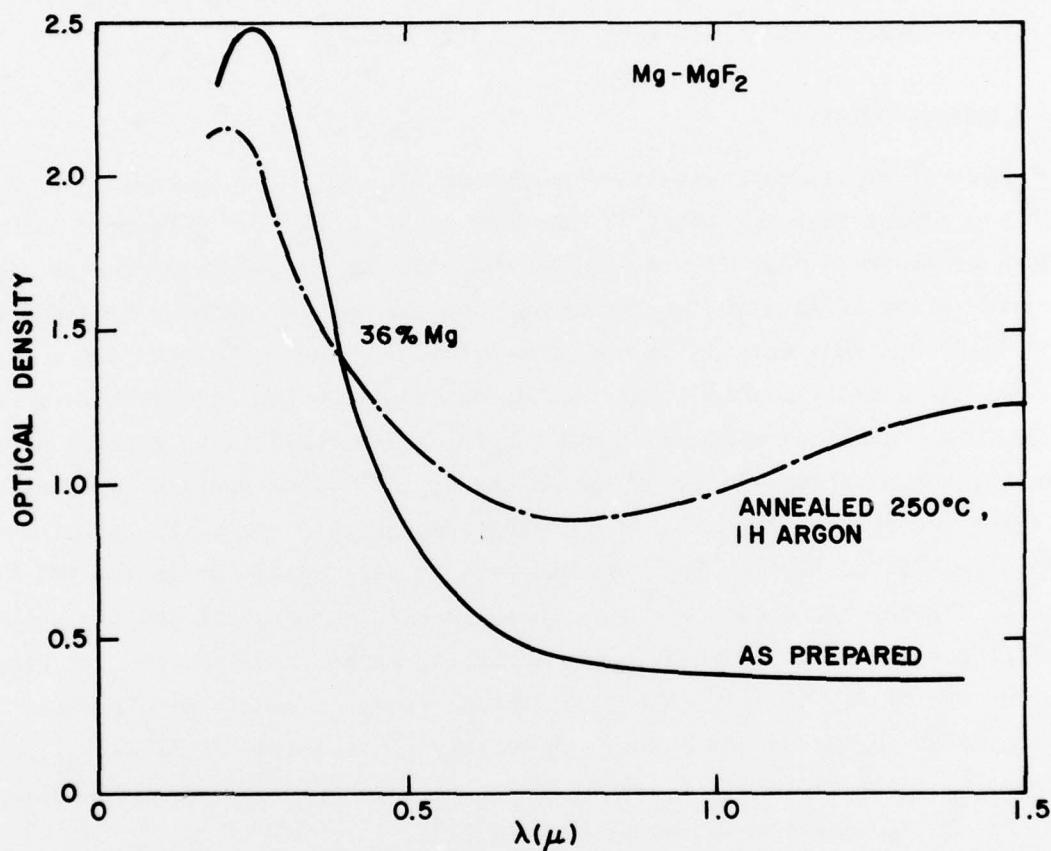


Figure 12. Experimental optical density spectra of Mg-MgF₂ cermets, 36 vol % Mg, as prepared and annealed.

We were unable to determine the composition of the Mg-MgF₂ samples by wet chemical analysis. To determine the amount of Mg that exists as metallic Mg, a determination of the weight of F in the sample was made and then it was assumed that all F was bound in MgF₂ molecules. The results were irreproducible. We therefore used a computer-generated composition profile [14] using the sputtering target geometry and the measured thickness gradient of a deposited Mg-MgF₂ sample. These are the volume compositions cited in the figures and should be treated as nominal values. Whenever MgO or MgO₂ is formed at the expense of Mg, the composition of the sample is changed. Both the electron micrographs and the Auger analysis found MgO present in the samples. Of course the computer-generated compositions profiles do not take oxides into account.

B. ALUMINUM CERMETS

Several experiments were also performed with Al metal systems. The M-G theory predicts that grains of Al embedded in Al₂O₃ have a dielectric anomaly near 2500 Å as shown in Fig. 13. A similar result would be predicted for an Al-SiO₂ cermet. Films of Al-Al₂O₃ were prepared and the optical density measured from 2000 to 7000 Å on a Cary 14 spectrophotometer. Instead of exhibiting a maximum, the optical density monotonically increased as wavelength decreased from 7000 to 2000 Å. Annealing samples at 600°C for 1 1/2 h resulted in a lower optical density, but no change in the shape of the curve. All annealing was done in an inert atmosphere (argon) or a reducing atmosphere (hydrogen). Samples of Al-SiO₂ exhibited similar behavior and were studied optically in the VUV to 1650 Å. There was no evidence of a sharp peak in the optical density below 2000 Å, but the optical density does saturate, rather than continue to rise. In the case of Al-SiO₂, it is likely that Al tends to reduce SiO₂ forming silicates and oxides of Al during sputtering. In the case of Al-Al₂O₃, the formation of suboxides of Al could reduce the amount of free Al. There are reports of Al₂O and AlO in the literature [15].

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13. E. Ritter in G. Hass, ed., *Physics of Thin Films*, Vol. 8 (Academic Press, New York, 1975).
 14. J. J. Hanak, H. W. Lehman, and R. K. Wehner, *J. Appl. Phys.* 43, 1666 (1972).
 15. Rodney P. Elliott, ed., *Constitution of Binary Alloys*, (McGraw Hill, N.Y., 1965) First Supplement.

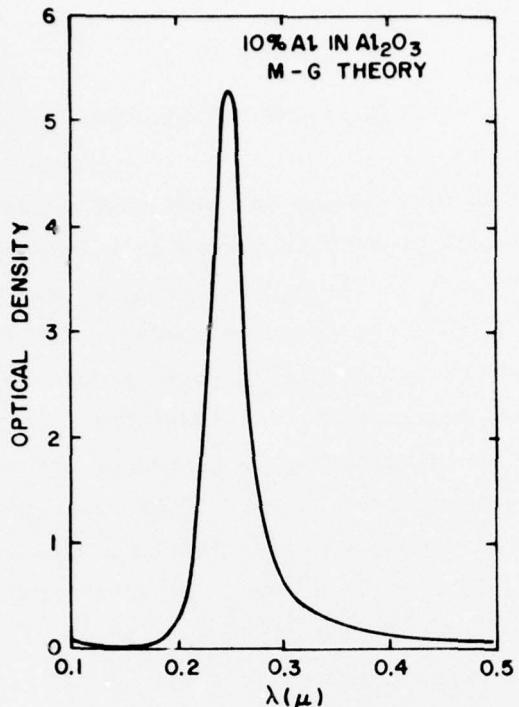


Figure 13. Theoretical optical density spectrum of Al-Al₂O₃ cermet for 10 vol % Al metal embedded in Al₂O₃ matrix.

C. OTHER SYSTEMS

Finally, it should be mentioned that Na metal in thin or discontinuous films would have the desired optical properties for a UV filter [16]. In fact, a number of the alkali metals are likely to have desirable optical properties. However, they are even more reactive than Al and Mg and are difficult to handle as they are not stable in room atmosphere.

16. Charles Kittel, *Introduction to Solid State Physics*, (John Wiley & Sons, N. Y., 1976) 3rd ed., p. 229.

SECTION V

SUMMARY AND CONCLUSIONS

Cermets of Al and Mg were chosen as those composites which would most closely exhibit the optical properties needed in a solar-blind filter. Films produced by co-sputtering Al and Al_2O_3 (alumina), Al and SiO_2 , Mg and MgO (pressed powder), and Mg and MgF_2 (pressed powder), all failed to exhibit the optical absorption band characteristic of cermets containing grains of a free electron metal dispersed in a transparent insulator. In the case of Al- SiO_2 there is evidence that the aluminum tends to reduce the quartz. Thus, this system is not a completely immiscible one. There is also evidence in the literature indicating that the aluminum-oxygen contains suboxides of Al. Thus, co-sputtering Al with either Al_2O_3 or SiO_2 failed to produce Al grains dispersed in an insulator. In the case of Mg-MgO, it is clear the pressed powder target contained excess oxygen, either as absorbed O_2 or as MgO_2 or both, which oxidized the Mg metal. The pressed powder MgF_2 target clearly contained absorbed O_2 .

On the other hand, the desired cermet ($\text{Mg}-\text{MgF}_2$) was formed when a single crystal MgF_2 target was used. However, the MgF_2 matrix was found to be porous and contained a large quantity of atmospheric oxygen. The presence of the O_2 limited the shelf life of the cermets and, more seriously, prevented the execution of definitive annealing studies.

Thus, before $\text{Mg}-\text{MgF}_2$ cermets can be made with the desired optical properties, methods of deposition must be found in which the MgF_2 matrix is nonporous, or in which the cermet is sealed before exposure to the atmosphere.

Other alkaline earth metals and some of the alkali metals may be preferable to magnesium. Indeed, there is evidence in the literature that sodium may be suitable. Materials suitable for the solar-blind filter are reactive metals; dispersing large grains of a reactive metal, a few hundred angstroms in diameter, has proved to be a difficult materials problem, one whose surface we have only scratched.

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